# Computational Microelectronics L7 (Pre-recorded)

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# 1D nonlinear Poisson equation

### Poisson equation

- Source-free Poisson equation
  - When the net charge density vanishes, we have a special form of the Poisson equation:

$$\nabla \cdot [\boldsymbol{\epsilon}(\mathbf{r}) \nabla \phi] = 0$$

Now we want to keep the net charge density.

$$\nabla \cdot [\boldsymbol{\epsilon}(\mathbf{r}) \nabla \phi] = -\rho(\mathbf{r})$$

Charges inside semiconductor

$$\rho(\mathbf{r}) = qp(\mathbf{r}) - qn(\mathbf{r}) + qN_{dop}^{+}(\mathbf{r})$$

- Hole density,  $p(\mathbf{r})$
- Electron density,  $n(\mathbf{r})$
- Doping density,  $N_{dop}^+(\mathbf{r})$ : Positive for donors and negative for acceptors

  GIST Lecture 2024

# At equilibrium,

- We have special expressions for charge densities:
  - -Hole density,  $p(\mathbf{r}) = n_{int}(\mathbf{r}) \exp\left(-\frac{q\phi(\mathbf{r})}{k_BT}\right)$
  - Electron density,  $n(\mathbf{r}) = n_{int}(\mathbf{r}) \exp\left(\frac{q\phi(\mathbf{r})}{k_BT}\right)$
  - By adopting these expressions, we have the nonlinear Poisson equation:

$$\nabla \cdot [\epsilon(\mathbf{r})\nabla\phi] + qn_{int}(\mathbf{r})\exp\left(-\frac{\phi(\mathbf{r})}{V_T}\right) - qn_{int}(\mathbf{r})\exp\left(\frac{\phi(\mathbf{r})}{V_T}\right) + qN_{don}^+(\mathbf{r}) = 0$$

#### Discretization

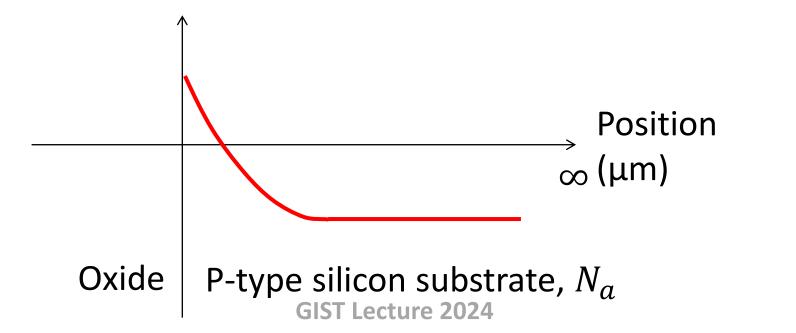
- When the nonlinear Poisson equation is considered,
  - We have additional terms related to  $\int_{x_{i-0.5}}^{x_{i+0.5}} \rho(\mathbf{r}) dx$ .
  - -Simple treatment for this integration:

$$\epsilon(x_{i+0.5}) \frac{\phi(x_{i+1}) - \phi(x_i)}{x_{i+1} - x_i} - \epsilon(x_{i-0.5}) \frac{\phi(x_i) - \phi(x_{i-1})}{x_i - x_{i-1}} + q\left(n_{int} \exp\left(-\frac{q\phi(x_i)}{k_B T}\right) - n_{int} \exp\left(\frac{q\phi(x_i)}{k_B T}\right) + N_{dop}^+(x_i)\right) (x_{i+0.5}) - x_{i-0.5}) = 0$$

– This expression is used to construct the i-th row of b vector.

# Only silicon region

- In general, we must consider the oxide layer and the gate contact.
  - For simplicity, consider only the silicon region.
  - -It is assumed that the surface potential,  $\phi_s = \phi(x=0) \phi_{\infty}$ , is known. Electrostatic potential (V)



## Once again, nonlinearity

- There are N unknown variables,  $\phi_0$ ,  $\phi_1$ , ...,  $\phi_{N-1}$ .

$$\begin{array}{l} -1) \text{ Evaluate the following equation at } N-2 \text{ points, } x_{1}, x_{2}, ..., x_{N-2}. \\ \varepsilon(x_{i+0.5}) \frac{\phi(x_{i+1}) - \phi(x_{i})}{x_{i+1} - x_{i}} - \varepsilon(x_{i-0.5}) \frac{\phi(x_{i}) - \phi(x_{i-1})}{x_{i} - x_{i-1}} \\ + q \left( n_{int} \exp\left( -\frac{q\phi(x_{i})}{k_{B}T} \right) - n_{int} \exp\left( \frac{q\phi(x_{i})}{k_{B}T} \right) + N_{dop}^{+}(x_{i}) \right) (x_{i+0.5}) \end{aligned}$$

 $-x_{i-0.5}$ ) = 0

-2) Apply the boundary condition at 2 points,  $x_0$  and  $x_{N-1}$ .

$$\phi_0 = \phi_s + \phi_\infty$$
$$\phi_{N-1} = \phi_\infty$$

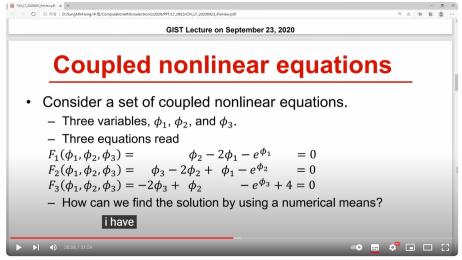
– It is nonlinear!

### **Newton-Raphson method**

- Newton method for multiple variables
  - For a single variable,  $\phi$ , we calculate  $f(\phi)$ . Its derivative,  $\frac{df}{d\phi}$ , is useful.
  - For two variables,  $\phi$  and  $\psi$ , we calculate  $f(\phi, \psi)$  and  $g(\phi, \psi)$ . Partial derivatives are  $\frac{\partial f}{\partial \phi}$ ,  $\frac{\partial f}{\partial \psi}$ ,  $\frac{\partial g}{\partial \phi}$ , and  $\frac{\partial g}{\partial \psi}$ . How can we arrange them to

calculate  $\delta\phi$  and  $\delta\psi$ ?

- -Watch my video [CM2020] L6.5 from 26:06.
- Key lesson:
- Partial derivatives construct A.
- -Then, solve Ax = b.



#### The *i*—th row

- Consider a case of  $1 \le i \le N-2$ .
  - -Then, (i, i+1) component becomes  $\epsilon(x_{i+0.5}) \frac{1}{x_{i+1} x_i}$ .

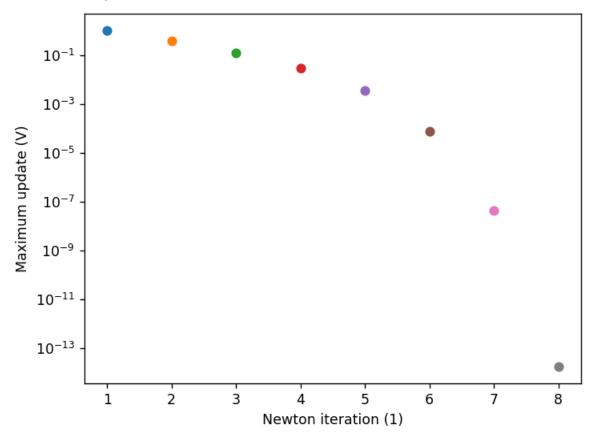
-The diagonal, 
$$(i, i)$$
, component becomes
$$-\epsilon(x_{i+0.5}) \frac{1}{x_{i+1} - x_i} - \epsilon(x_{i-0.5}) \frac{1}{x_i - x_{i-1}}$$

$$+ q \left( -\frac{q}{k_B T} n_{int} \exp\left( -\frac{q\phi(x_i)}{k_B T} \right) - \frac{q}{k_B T} n_{int} \exp\left( \frac{q\phi(x_i)}{k_B T} \right) \right) (x_{i+0.5} - x_{i-0.5})$$

-Also, (i, i-1) component becomes  $\epsilon(x_{i-0.5}) \frac{1}{x_{i-1}x_{i-1}}$ .

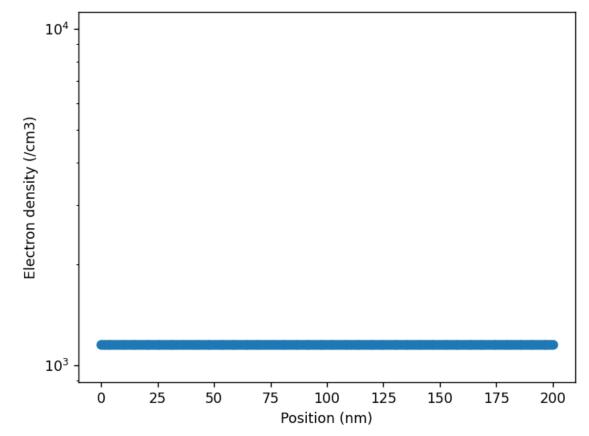
### Convergence criterion

- By solving Ax = b, we obtain a vector of  $\delta \phi$  .
  - When every entry of this vector becomes sufficiently small, we can stop the Newton-Raphson iterations.



#### Flatband condition

- It means that  $\phi_s$  = 0.0 V.
  - Also, the p-type doping concentration is  $10^{17}$  cm<sup>-3</sup>.
  - -Use  $\Delta x = 1$  nm. N is 201.

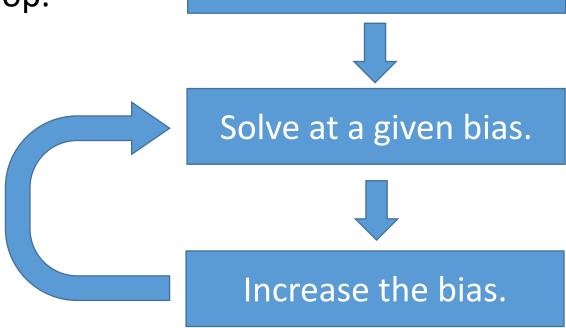


# Bias ramping

• Ramp up the surface potential,  $\phi_s$ . (The term, "bias," is usually used for terminal quantities. In this lecture, we instead increase

 $\phi_{S}$ , only for simplicity.)

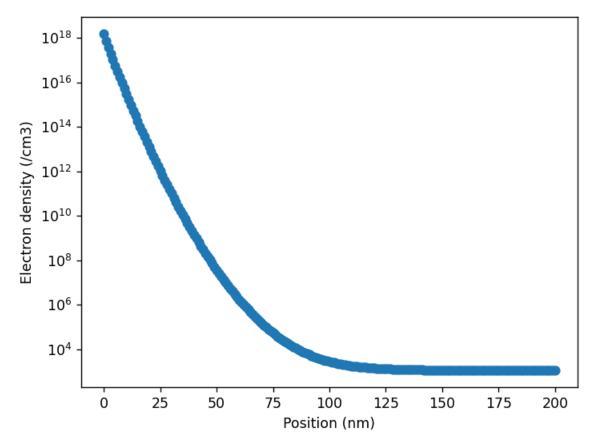
-Simply add an outermost loop.



Start at the initial bias.

# Electron density at $\phi_S$ = 0.9 V

- Now, strong inversion
  - -The electron density at x = 0 is  $1.5 \times 10^{18}$  cm<sup>-3</sup>.
  - Numerically integrated electron density is 2.3X10<sup>11</sup> cm<sup>-2</sup>.



#### Homework#7

- Due: AM08:00, October 8
- Problem#1
  - Now, we have two methods to calculate semiconductor charges. One is an analytic expression studied in L4. The other is a numerical approach studied in L7. When the p-type doping concentration is 4X10<sup>17</sup> cm<sup>-3</sup>, compare two results.

# Thank you for your attention!